

Docket No.: 21806-00157-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Robert T. Froebel et al.

Application No.: 10/707,864

Confirmation No.: 1863

Filed: January 19, 2004

Art Unit: 2877

For: ALIGNMENT MARK SYSTEM AND
METHOD TO IMPROVE WAFER
ALIGNMENT SEARCH RANGE

Examiner: Akanbi, Iiaka

AMENDMENT

MS Amendment

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action mailed February 9, 2006, please amend the above-identified U.S. patent application as follows:

LISTING OF THE CLAIMS begin on page 2.

REMARKS begin on page 7.